



Docket No.: 50099-184

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Masato FUJINAGA

Serial No.:

Group Art Unit:

Filed: October 16, 2001

Examiner:

For: HIGH-FREQUENCY SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING THE SAME

**CLAIM OF PRIORITY AND
TRANSMITTAL OF CERTIFIED PRIORITY DOCUMENT**

Commissioner for Patents
Washington, DC 20231

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicant hereby claims the priority of:

Japanese Patent Application No. 2000-349807, filed November 16, 2000

cited in the Declaration of the present application. A certified copy is submitted herewith.

Respectfully submitted,

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日本国特許庁
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JAPANESE GOVERNMENT

50099-184
Masato Fujinaga
October 16, 2001

McDermott, Will & Emery

別紙添付の書類に記載されている事項は下記の出願書類に記載されて
いる事項と同一であることを証明する。
This is to certify that the annexed is a true copy of the following application as filed
with this Office.

出願年月日
Date of Application:

2000年11月16日

出願番号
Application Number:

特願2000-349807

出願人
Applicant(s):

三菱電機株式会社

2000年12月 8日

特許庁長官
Commissioner,
Patent Office

及川耕造

